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**Bib Data Sheet** 

**CONFIRMATION NO. 8732** 

SERIAL NUMBEI 09/086,772	FILING OR 371(c)  DATE  05/29/1998  RULE	<b>CLASS</b> 216		DUP ART UNIT 1754		ATTORNEY DOCKET NO. TSMC97-306	
MING-HSIN I	JANG, HSIN-CHU, TAIW HUANG, HSIN-CHU, TAIV ATA ***********************************	VAN; ∗					
Foreign Priority claimed 35 USC 119 (a-d) condit met Verified and Acknowledged	STATE OR COUNTRY TAIWAN	SHEETS DRAWING 2	TOT CLA	IMS	INDEPENDENT CLAIMS 2		
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TITLE HARD MASKING M LAYER	IETHOD FOR FORMING	PATTERNED OXYGE	N CONTAIN	NG PLAS	MA E	TCHABLE	
			☐ All Fees				
	FEES: Authority has been given in Paper  No to charge/credit DEPOSIT ACCOUNT  No for following:			1.16 Fees ( Filing )			
FILING FEE FE				1.17 Fees ( Processing Ext. of time )			
790 No				☐ 1.18 Fees ( Issue )			
			Other				
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SERIAL NUMBER		FILING DATE	CLASS	GROUP ART	UNIT A	TTORNEY DOCKET NO.					
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SYUN-MING JANG, HSIN-CHU, TAIWAN; MING-HSIN HUANG, HSIN-CHU, TAIWAN.											
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HARD MASKING METHOD FOR FORMING PATTERNED OXYGEN CONTAINING PLASMA  ETCHABLE LAYER											
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